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Patent

Attorney's Docket No. 018765-171

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of)	MAIL STOP NEW APPLICATION
Masafumi MIYAKAWA et al.)	Group Art Unit:
Application No.:)	Examiner:
Filed: September 10, 2004)	Confirmation No.:
For: PRESSURE-SENSITIVE ADHESIVE)	
FILM FOR THE SURFACE)	
PROTECTION OF SEMICONDUCTOR)	
WAFERS AND METHOD FOR)	
PROTECTION OF SEMICONDUCTOR)	
WAFERS WITH THE FILM)	

PRELIMINARY AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Prior to calculation of the filing fee, please amend the above-identified patent application as follows: